Se	arch	Note	es

Application/Control No.	Applicant(s)/Patent under Reexamination
10/047,177	LAI, YHEAN-SEN
Examiner	Art Unit
Erin M. File	2634

	SEARCHED			
Class	Subclass	Date	Examiner	
375	348	11/18/2005	EMF	
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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
	kt Search out History	11/18/2005	EMF

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
EAST US PAT, USPGPUB, EPO, JPO DERWENT, IBM (text search only—see search history printout)	11/18/2005	EMF